



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Masahiro SAKURADA et al.

Group Art Unit: 2812

Application No.: 10/542,376

Docket No.: 124703

Filed: July 14, 2005

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For: AN SOI WAFER AND A METHOD FOR PRODUCING THE SAME

REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

William P. Berriege Registration No. 30,024

John W. Fitzpatrick Registration No. 41,018

WPB:JWF/crh

Date: March 8, 2006

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461



ART UNIT

2812

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APPL NO.

10/542,376

FILING OR 371

(c) DATE

07/14/2005



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CONFIRMATION NO. 7788

FILING RECEIPT *OC000000017959620*

Date Mailed: 02/14/2006

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Applicant(s)

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Assignment For Published Patent Application

SHIN-ETSU HANDOTAI CO., LTD., TOKYO, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 25944.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/00547 01/22/2004

Foreign Applications

JAPAN 2003-015396 01/23/2003 JAPAN 2003-015072 01/23/2003 * Please Se *
p. 2 for correction

Projected Publication Date: To Be Determined - pending completion of Security Review

Non-Publication Request: No

Early Publication Request: No

Title

-Soi wafer and production method therefor

AN SOI WAFTER AND A METHOD FOR PRODUCING THE SAME

Preliminary Class

438

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